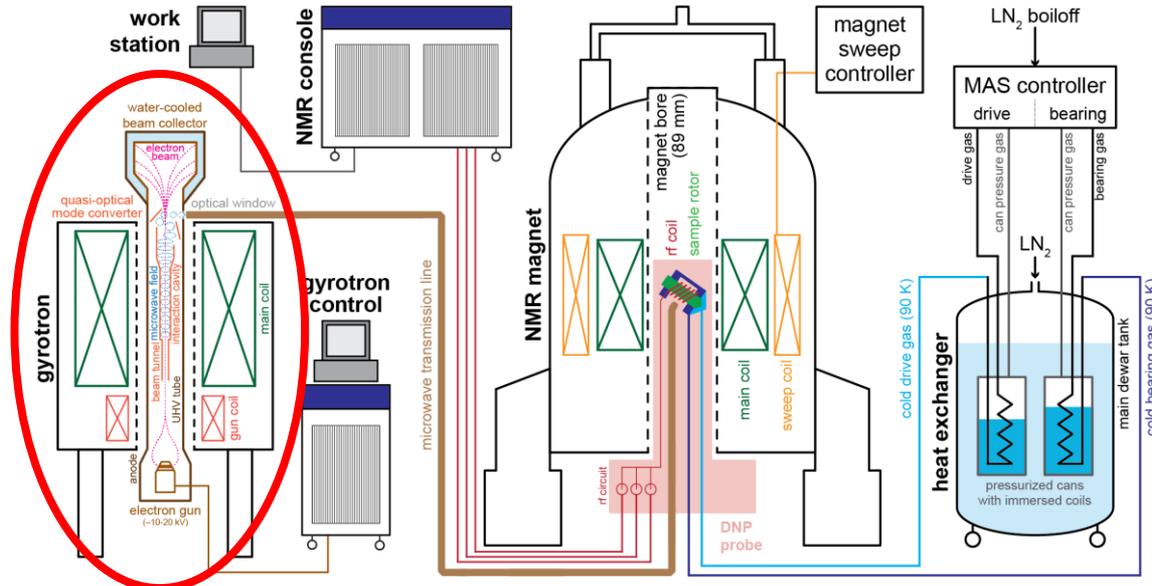


Ongoing Development of a Helical-Type Gyro-TWT for 263 GHz DNP-NMR at IHM

Max Vöhringer



Motivation



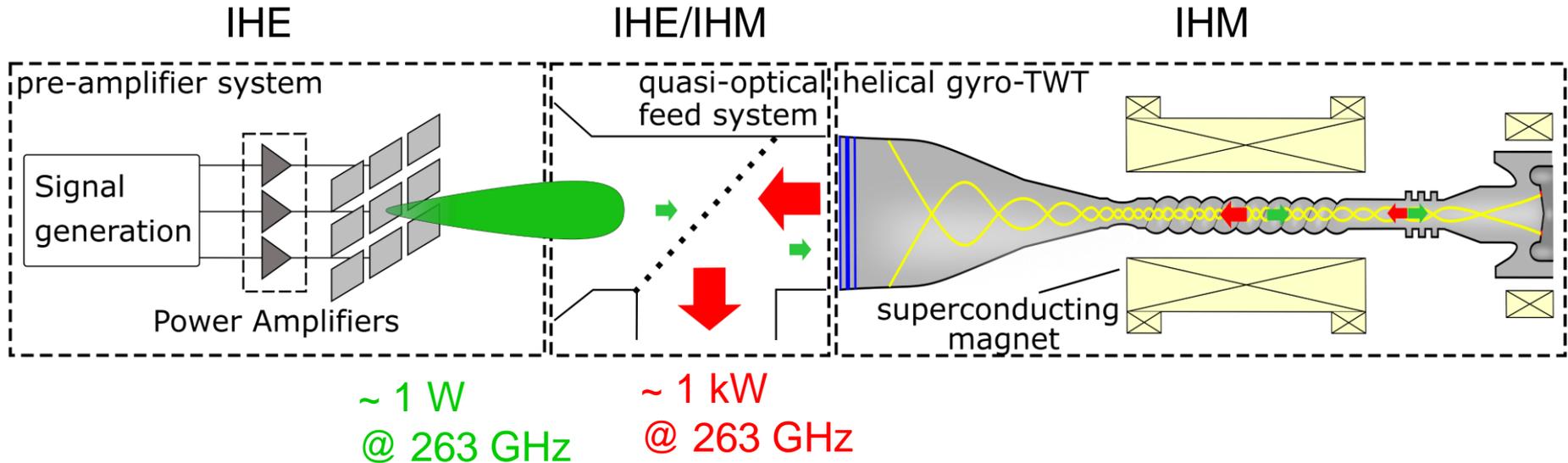
Gyrotron can only produce CW power

Coherent pulse sequences are desired

Microwave amplifier

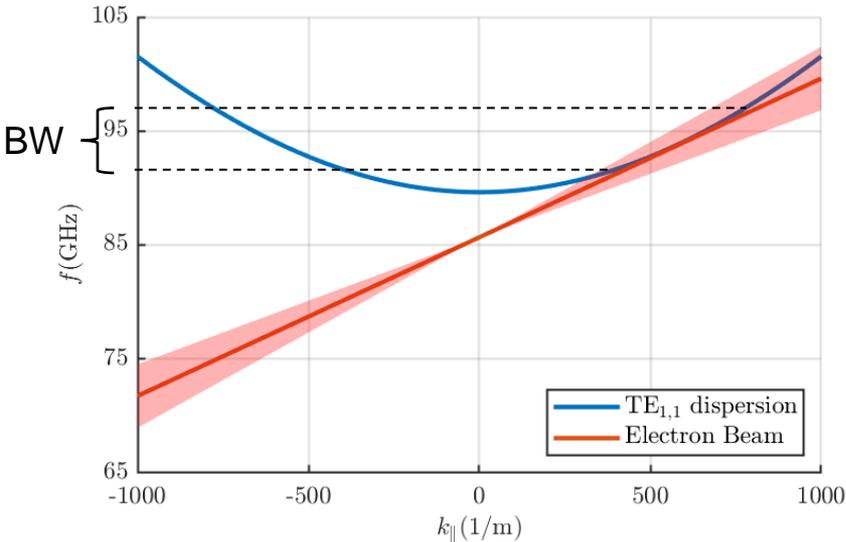
Project B01

- Broadband sub-THz high-power amplifier system for high-field pulsed DNP



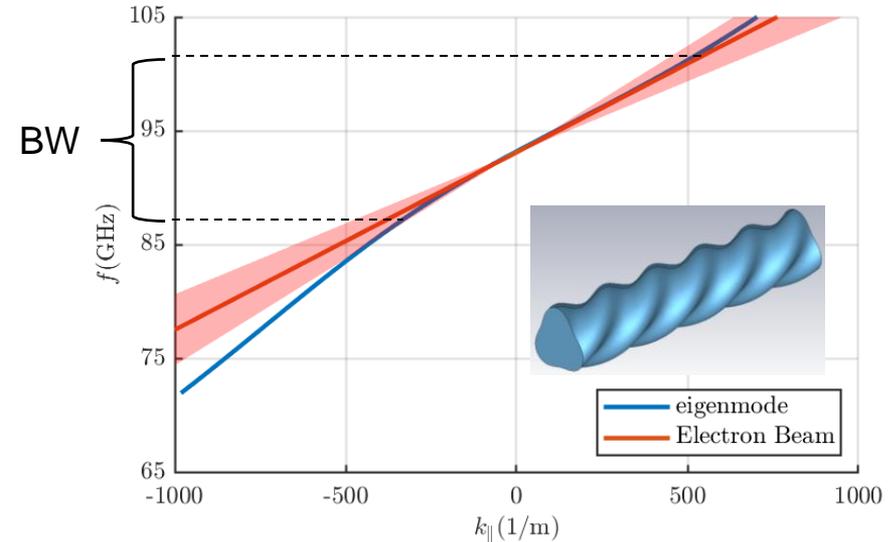
Interaction Region

Circular Interaction Region



$$\omega \approx s\omega_c + k_{||}v_{||}$$

Helically Corrugated Interaction Region (HCIR)



- higher bandwidth
- better resilience against velocity spreads

Helicallly corrugated interaction region (HCIR)

$$r(\theta, z) = r_0 + r_1 \cos\left(m_B \theta + \frac{2\pi z}{d}\right)$$

$m_B = 3$



[1]

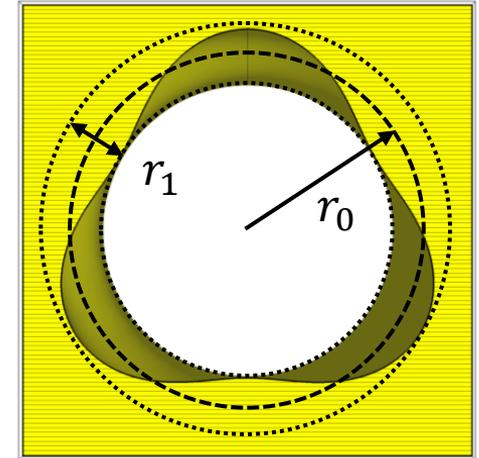


[1]

$m_B = 8$



[2]



[1] C. R. Donaldson, L. Zhang, C. W. Robertson, P. MacInnes, and C. G. Whyte, "Helicallly corrugated interaction regions for W-band gyrotron-Traveling Wave Amplifiers," doi: [10.23919/EuMC58039.2023.10290435](https://doi.org/10.23919/EuMC58039.2023.10290435).
 [2] C. R. Donaldson et al., "8-Fold Helicallly Corrugated Interaction Region for High Power Gyroresonant THz Sources," doi: 10.1109/LED.2021.3105435.

Helically corrugated interaction region (HCIR)



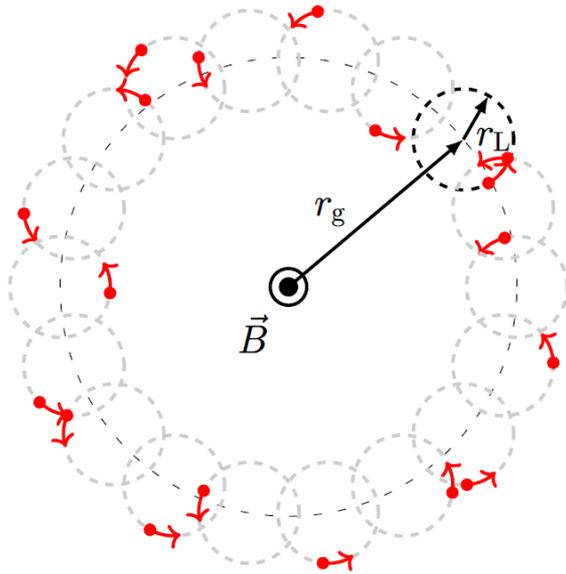
First trials milling a mandril at 94 GHz



Mandril for the first electroplating trials
at 94 GHz

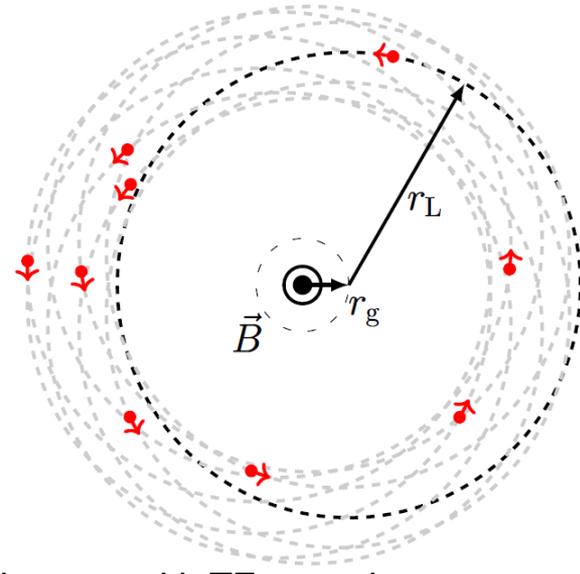
Electron Beams at the Interaction Region

Small Orbit Beam



- Usually used in high power gyrotrons
- Interacts with higher order modes

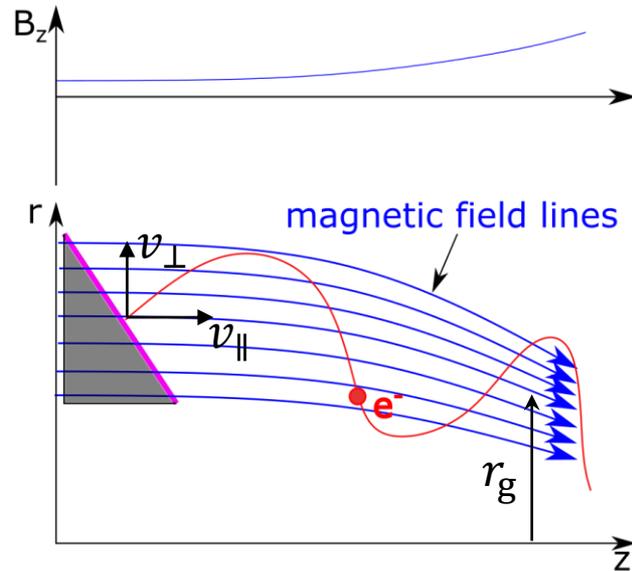
Large Orbit Beam



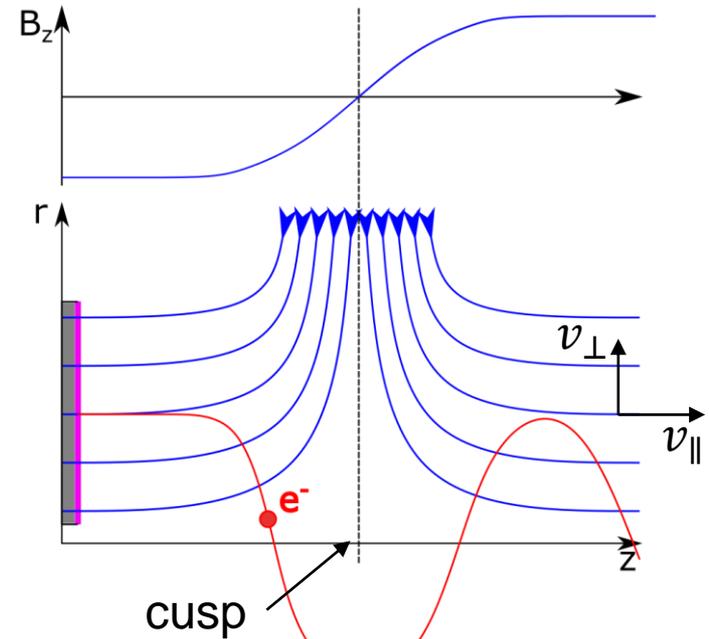
- Only interact with $TE_{s,1}$ -modes
- Remember: Eigenmode of HCIR similar to $TE_{2,1}$
 $\rightarrow s = 2$: 2nd – harmonic operation

Generation of Electron Beams

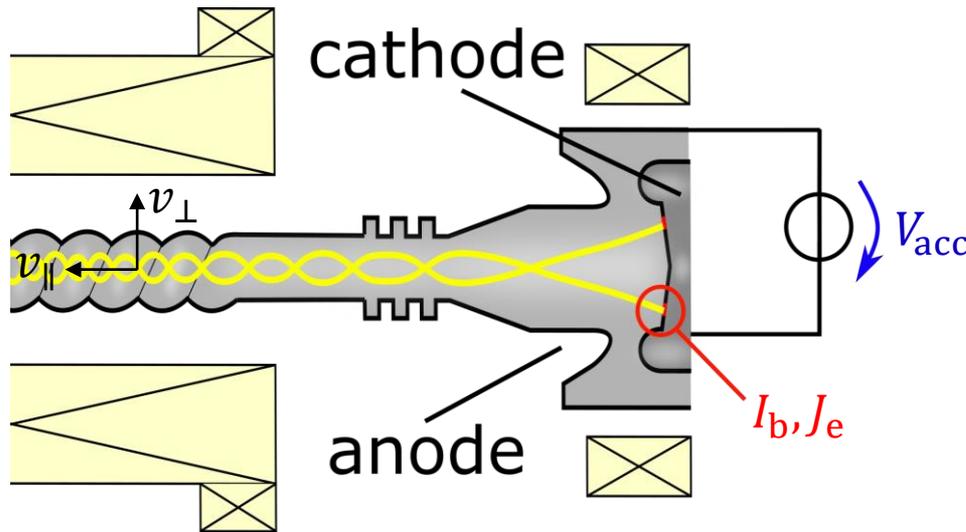
Small Orbit Beam



Large Orbit Beam



Generation of Electron Beams

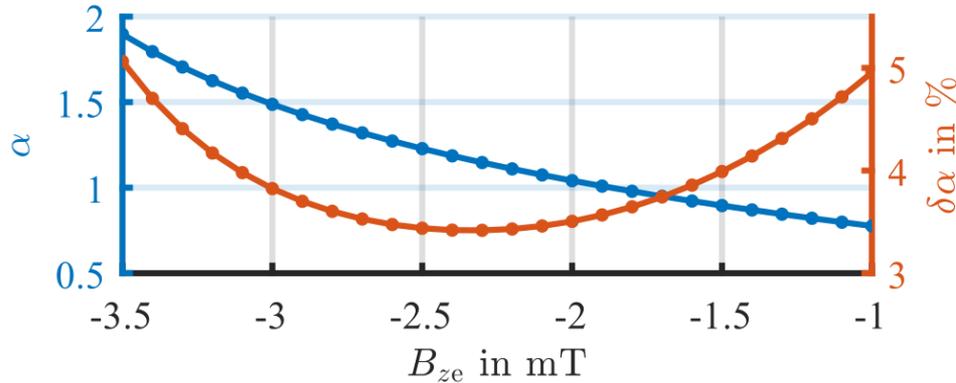


- Pitch factor $\alpha = \frac{v_{\perp}}{v_{\parallel}} = 1.0$
- Acceleration voltage $V_{acc} = 50 \text{ kV}$
- Electron beam current $I_b = 0.25 \dots 0.6 \text{ A}$
- Emitter current density $J_e < 4 \frac{\text{A}}{\text{cm}^2}$
- Magnetic flux density at the interaction region $B_{zi} = 5.1 \text{ T} \hat{=} 263 \text{ GHz}$



Change of operation frequency

Change of Pitch Factor α

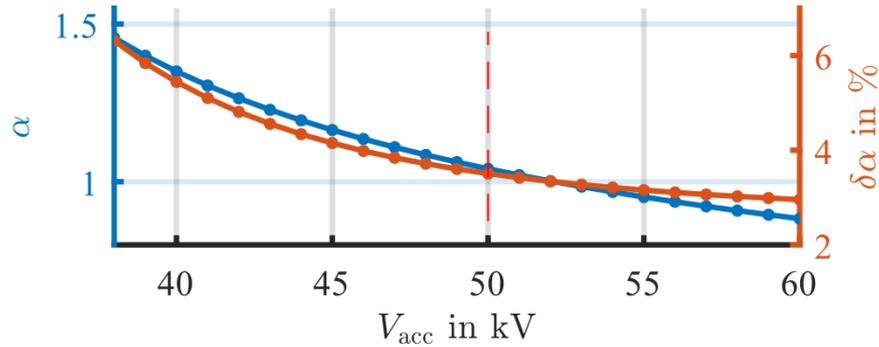


➔ Pitch factor α can easily altered by a slight change of the magnetic flux density

➔ Only slight change of $\delta\alpha$ operation from $\alpha = 0.8 \dots 1.9$ is possible.

➔ The Pitch Factor $\alpha = \frac{v_{\perp}}{v_{\parallel}}$, which indicates the energy content in transversal dimension, can be adjusted

Change in beam power



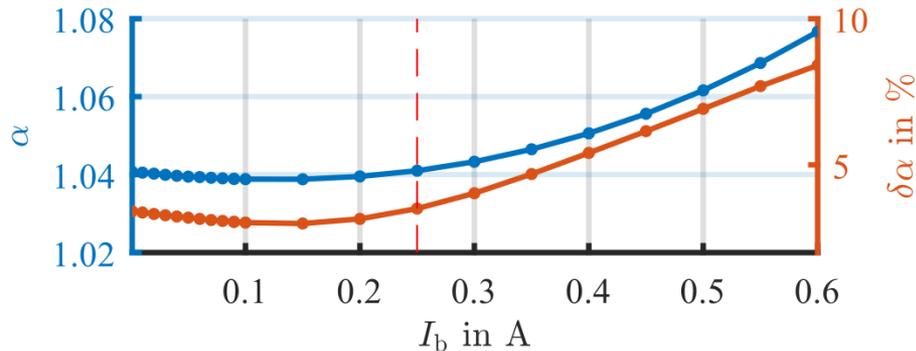
Voltage change causes large change in α



$\delta\alpha$ increases only for lower voltages



Can be compensated by adjusting B_{ze}



Current change causes small change in α



$\delta\alpha$ increases for higher currents



Increase of power via I_b is limited by $\delta\alpha$

Operation at 94 and 140 GHz

Operation at 94 GHz

- $B_{zi} = 1.82 \text{ T}$
- $\delta\alpha = 3.3 \%$ (RMS), for $\alpha = 1.0$

➔ To keep the pitch factor α constant, the magnetic flux density must be changed to $B_{ze} = -6.0 \text{ mT}$

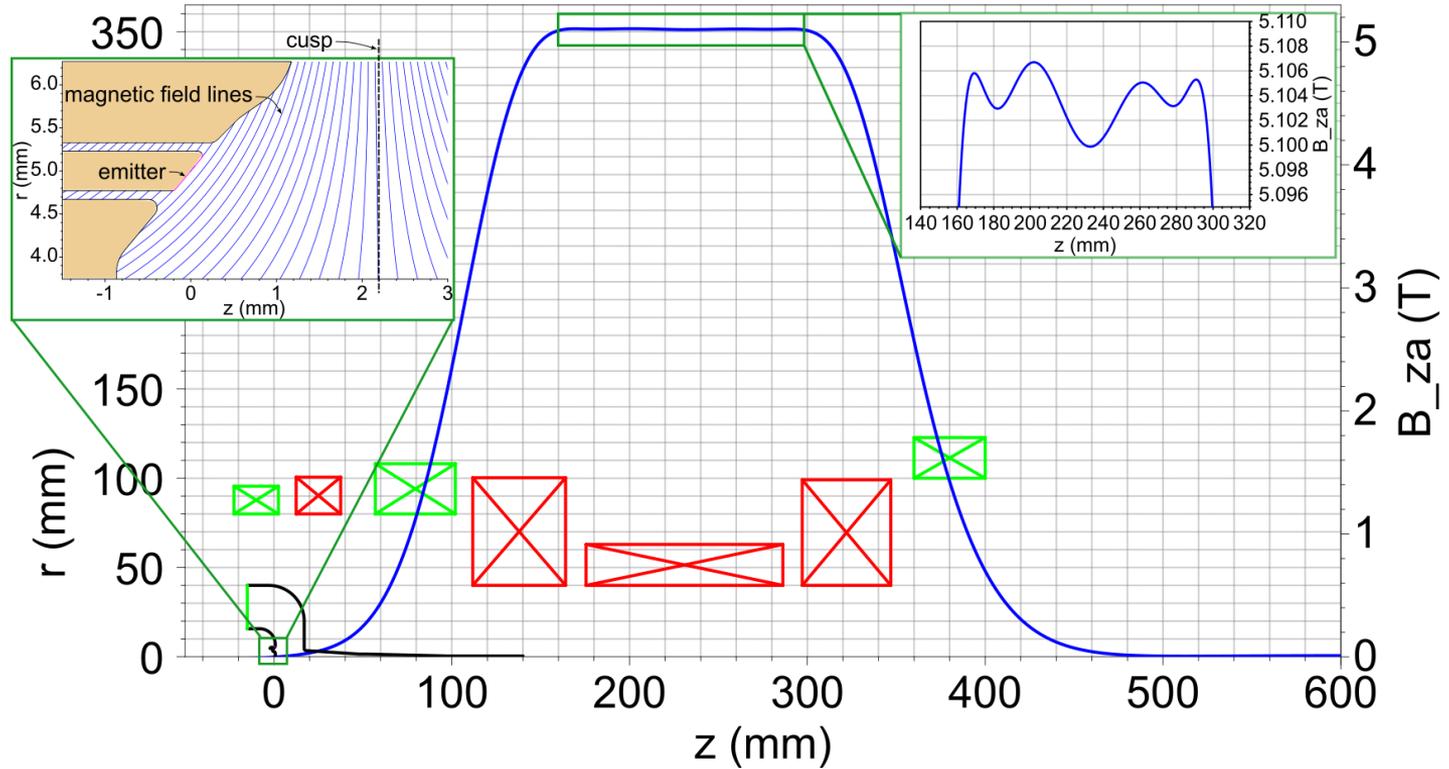
Operation at 140 GHz

- $B_{zi} = 2.71 \text{ T}$
- $\delta\alpha = 2.5 \%$ (RMS), for $\alpha = 1.0$

➔ To keep the pitch factor α constant, the magnetic flux density must be changed to $B_{ze} = -4.5 \text{ mT}$

➔ Magnetic flux density at the interaction region, as well as at the emitter must be adjustable

Superconducting Magnet



Operation Parameters



Beam Parameters

Beam Current:

$$I_b = 0.6 \text{ A}$$

Acceleration Voltage:

$$V_{\text{acc}} = 50 \text{ kV}$$

Pitch Factor:

$$\alpha = \frac{v_t}{v_z} = 1.0$$

Input Signal

Input power:

$$P_{\text{in}} = 1 \text{ W}$$

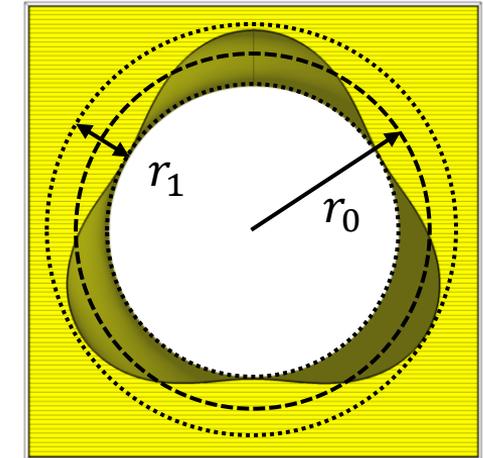
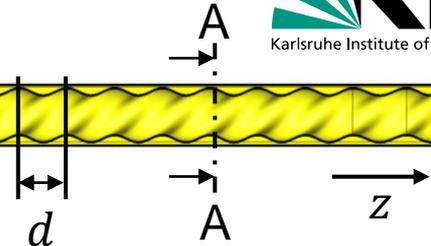
HCIR Parameters

$$d = 1.16 \text{ mm}$$

$$r_0 = 0.544 \text{ mm}$$

$$r_1 = 0.08 \text{ mm}$$

$$\text{Length} = 32 \cdot d$$



A - A

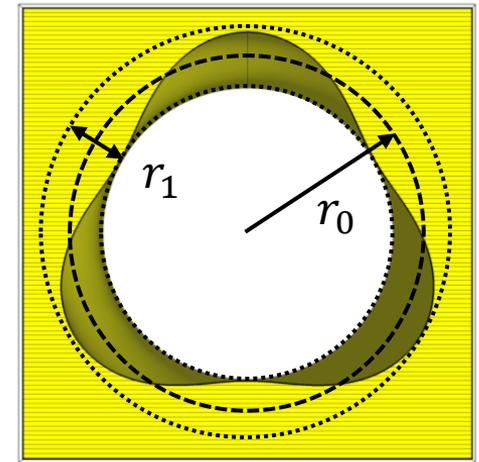
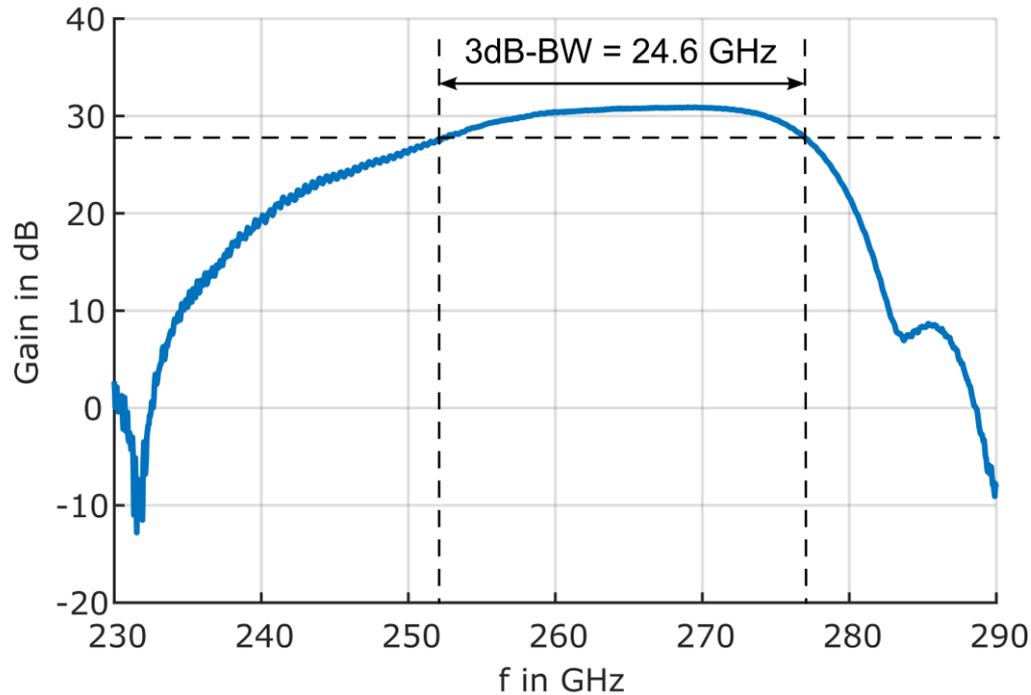
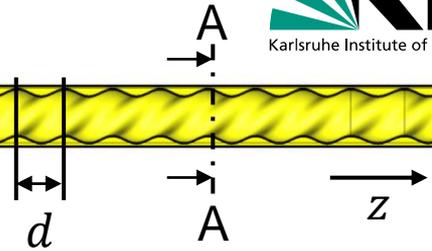
Output Power:

$$P_{\text{out}} = 1 \text{ kW}$$

Gain:

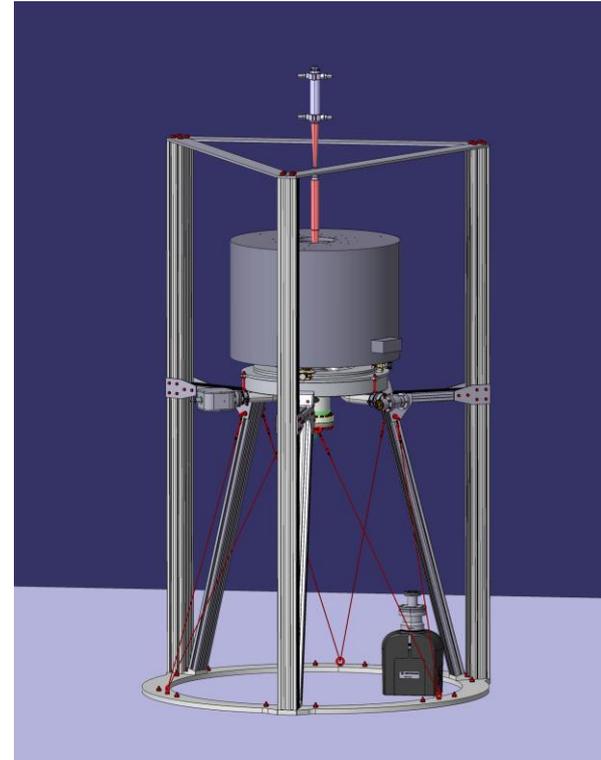
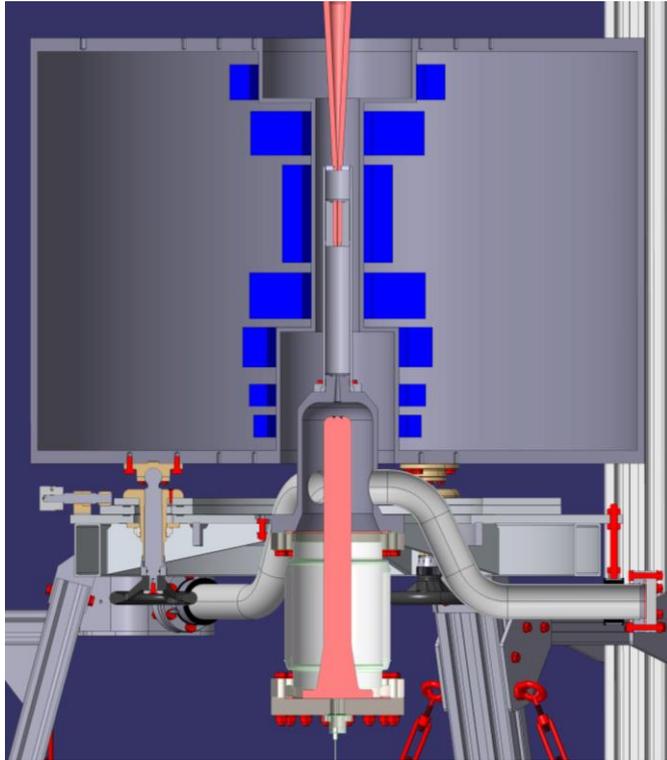
$$G = 30 \text{ dB}$$

3dB - Bandwidth



A - A

Mechanical Design and Teststand



Conclusion and Outlook

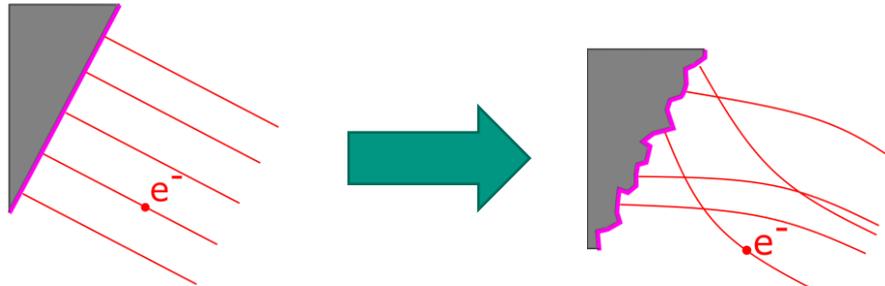
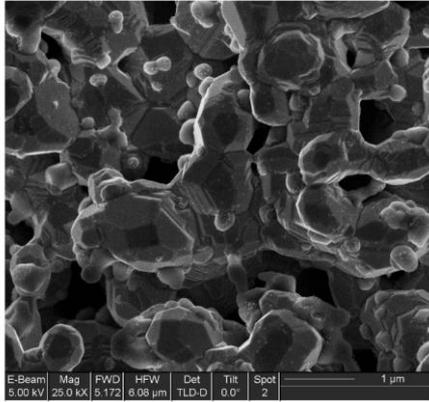
- Manufacturing of 94 GHz HCIR started
- Electron gun for multiple operation points and frequencies is designed
- Superconducting magnet is ordered



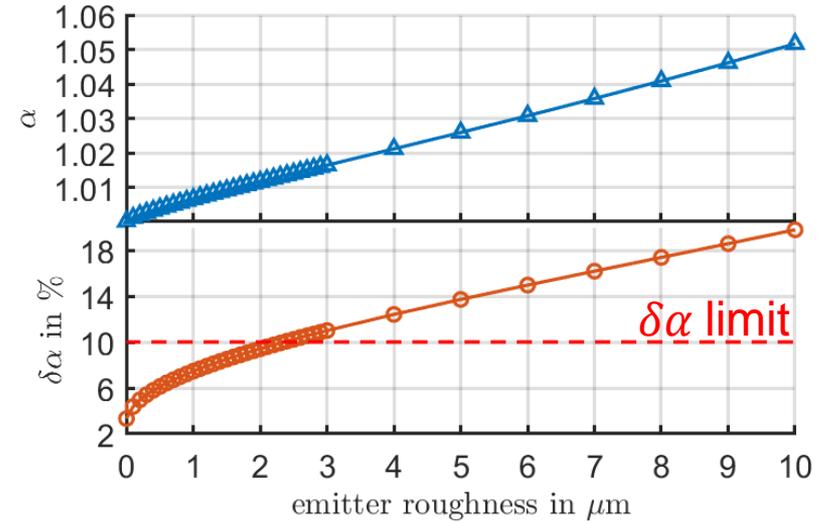
- Manufacturing of 263 GHz mandril
- Manufacturing of teststand
- Ordering of the electron emitter and manufacturing electron gun

Backup Slides

Emitter Roughness



$$\delta\alpha = 3.45 \%$$



- With increasing surface roughness the pitch factor spread increases rapidly

→ A $\delta\alpha \leq 10.0 \%$ can be reached up to a surface roughness of 2.3 μm .